

Notice of References Cited	Application/Control No. 10/777,508	Applicant(s)/Patent Under Reexamination ALDEREGUIA ET AL.	
	Examiner Wutchung Chu	Art Unit 2619	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0158940	08-2003	Leigh, Kevin B.	709/226
*	B	US-2004/0057448	03-2004	Nakamura, Atsushi	370/428
*	C	US-6,286,073	09-2001	Vegter, Kornelis Hendrik	710/313
*	D	US-5,530,842	06-1996	Abraham et al.	709/221
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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